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PATENT  
Customer No. 22,852  
Attorney Docket No. 7553.0008

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Chishio KOSHIMIZU et al. ) Group Art Unit: 1765  
Application No: 09/665,940 ) Examiner: L. UMEZ ERONINI  
Filed: September 21, 2000 )  
For: PLASMA PROCESSING )  
APPARATUS AND PLASMA )  
PROCESSING METHOD )

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action dated March 29, 2004, the period for response  
extending to June 29, 2004, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.  
**Remarks** follow the amendment sections of this paper.